

Electronic Patent Application Fee Transmittal

Application Number:	10529861			
Filing Date:	31-Mar-2005			
Title of Invention:	PLASMA TREATMENT APPARATUS, METHOD OF PRODUCING REACTION VESSEL FOR PLASMA GENERATION, AND PLASMA TREATMENT METHOD			
First Named Inventor/Applicant Name:	Tetsuji Shibata			
Filer:	Lee Cheng/Maki Huffman			
Attorney Docket Number:	HOK-0270			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appt Issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	3	3	9
Total in USD (\$)				1749